

## **Coating thermal noise**

(QN: 2MW FPMI or 500W RSE with RG 20 x SQ 20dB, 5% loss, w/filter cavity, L=5km, m=100kg, F=60 for FPMI)



We need a factor of 20 improvement from AdLIGO (16 if L=5km)

## **Coating thermal noise**

How can we reduce TN by a factor of 16? (256 in Sx)

$$S_x(\Omega) = \frac{4k_{\rm B}T}{\Omega} \frac{(1+\sigma_c)(1-2\sigma_c)2d_{\rm coa}}{\pi E_c w_0^2} \phi_c$$

- T could be reduced by 20 (cryogenic)
- $\phi_c$  could be reduced by 2 (doped tantala)
- wo could be increased by 1.36 (larger mass)
- wo could be effectively increased by 1.4 (mesa beam)

#### We need another factor of 3~4 improvement

How?  $\longrightarrow$  Let us decrease  $d_{coa}$  (= $\lambda/4xN/n$ )

### **Power balance**



QN curves are same. What's the difference?

- The lower the finesse, the higher laser noise and BS noise
- The lower the finesse, the less coating on ITM
- (Practical difference; imbalances, heat problem, etc.)

## Lowering the ITM reflectivity



- However, the benefit is small (~only 4% improvement in Sx)
- Contribution of the ETM is much larger



- Almost same reflectivity with less coatings
- Heat problem is as small as the ITM
- EETM noise is negligible
- Coating noise is reduced by 16/27 in Sx
- Can we further decrease N?

# 4-mirror cavity system



Reduction of N<sub>2</sub> is effective as we reduce N<sub>3</sub> at the same time.

On the other hand, reducing N<sub>2</sub> and N<sub>3</sub> results in...

- noise from EETM and BS
- TR noise from ITM, IETM sub.

• lase noise, heat problem, etc.

These can be suppressed by control!!

## **Rigid end-mirror cavity**





#### **QL of excess ctrl noise**



There is a minimum with appropriate A1<sup>s</sup>/A1<sup>c</sup> at each freq.

Quantum Limit of excess ctrl noise!!

## **QL of excess noise vs TN of ETMC**

#### [quant-ph 0811.1780v]



without the rigid control, N=2 is the optimal number
with the rigid control, N=1 is the optimal number
Note that QL can be reached only at one frequency

## **QL of excess noise vs TN of ETMC**

m=40kg, T=300K



Total noise level of ETMC N=1 w/o ctrl: 2.27e-21 m/rtHz at 100Hz N=2 w/o ctrl: 1.95e-21 m/rtHz at 100Hz N=1 with ctrl: 1.65e-21 m/rtHz at 100Hz N=2 with ctrl: 1.79e-21 m/rtHz at 100Hz

## **QND control of ETMC**

We can do a sort of variational readout scheme

~ Feeding back the RPN information to EETM so that RPN of IETM cancel.

$$\begin{split} z_2^{\mathrm{VR}} &= a_2^{\mathrm{c}} - \tilde{r}\mathcal{K}a_1^{\mathrm{c}} + \frac{\sqrt{2\mathcal{K}}}{x_{\mathrm{SQL}}}\tilde{r}x & \text{readout phase} \\ &+ \frac{A_1^{\mathrm{c}}(1-r)^2}{A_1^{\mathrm{s}}(1+r)^2}(a_2^{\mathrm{s}} + a_1^{\mathrm{s}}\tan\zeta) - \tilde{r}\mathcal{K}\frac{A_1^{\mathrm{s}}}{A_1^{\mathrm{c}}}a_1^{\mathrm{s}} \end{split}$$

**RPN** can be cancelled

VR + Filter + high-power SB no excess noise!
N=0 is in principle possible (no coating noise)!

# **Summary**

- We need a factor of 2~4 reduction of coat TN for ET
- Conventional end-mirror cavity helps a factor of 1.3
- The more decreasing N, the more EETM noise
- EETM noise can be suppressed by a control
- The control imposes excess shot noise
- Increasing the ctrl SB power results in RP noise
- Quantum limit of excess ctrl noise exists
- QND control can erase excess noise
- Coating-free is in principle possible
- Heat problem will be an issue